

L Number	Hits	Search Text	DB	Time stamp
1	1196	(indium adj2 oxide) near5 (thin adj film)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/12 15:28
2	26	((indium adj2 oxide) near5 (thin adj film)) and waveguide\$1	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/12 14:16
3	782	(indium adj tin adj oxide) near5 (thin adj film)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/12 15:22
4	22	((indium adj tin adj oxide) near5 (thin adj film)) and waveguide\$1	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/12 15:22
5	2152	(chromium) near5 (thin adj film)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/12 15:29
6	47	((chromium) near5 (thin adj film)) and waveguide\$1	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/12 15:30
-	282	conductive adj thin adj film adj layer\$1	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/11 17:04
-	116	(conductive adj thin adj film adj layer\$1) and (oxide)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/11 17:04
-	94	((conductive adj thin adj film adj layer\$1) and (oxide)) and (oxide near10 layer\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/11 17:05
-	19	((conductive adj thin adj film adj layer\$1) and (oxide)) and (oxide near10 layer\$1)) and (indium adj oxide)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/11 17:07
-	3	((conductive adj thin adj film adj layer\$1) and (oxide)) and (oxide near10 layer\$1)) and (indium adj oxide)) and waveguide\$1	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/12 13:45
-	30193	indium adj2 oxide	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/12 13:47
-	241	(indium adj2 oxide) and (waveguide\$1 near5 substrate)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/12 13:47
-	155	((indium adj2 oxide) and (waveguide\$1 near5 substrate)) and (thin adj film)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/12 13:48
-	155	((indium adj2 oxide) and (waveguide\$1 near5 substrate)) and (thin adj film)) and (oxide)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/12 13:51
-	50	((indium adj2 oxide) and (waveguide\$1 near5 substrate)) and (thin adj film)) and (chromium)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/12 14:14